## CERTIFICATE OF MAILING

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Docket: 0756-1139

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:	)	
Shunpei YAMAZAKI et al.	)	
Serial No. 08/355,652	)	Examiner Chaudhari
Filed: December 14, 1994	)	Art Unit: 1104
For: LASER PROCESSING METHOD,	)	
METHOD FOR FORMING A	)	
FLASH MEMORY, INSULATED	)	
GATE SEMICONDUCTOR DEVICE	)	
AND METHOD FOR FORMING	)	
THE SAME	)	February 7 1996

## **AMENDMENT**

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Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

**GROUP 1100** 

Sir:

In response to the Office Action mailed August 8, 1995, please amend the above-identified application as follows.

## IN THE CLAIMS:

Please amend claims 21, 26, 31, 36, 41, 45, 36 and 49 as follows:

21. (Amended) A laser processing method comprising: forming a gate member on a semiconductor;